

OCT. 11. 2005 5:48PM

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NO. 4484 P. 3

OCT 11 2005

Docket No. 740756-2659

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

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ENTER
10/16/05*

In re Patent Application of:

Shunpei YAMAZAKI et al.

Serial No. 10/678,139

Filed: October 6, 2003

For: METHOD FOR FABRICATING
SEMICONDUCTOR THIN FILM

-)
Group Art Unit: 2822
) Examiner: Maria F. Guerrero
>) Confirmation No. 9428
>) Date: October 11, 2005

CERTIFICATE OF MAILING OR TRANSMISSION
[37 CFR 1.8(a)]

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Signature: 

Name: Jeffrey J. Costello

AMENDMENT

Mail Stop AF
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

In response to the Office Action mailed July 11, 2005, please amend the above identified application as follows.

W691271.1